



Docket No.: GR 97 P 2734

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Frank Hintermaier
Applic. No. : 09/161,196
Filed : September 25, 1998
Title : Capacitor Having A Barrier Layer Made Of A Transition
Metal Phosphide, Arsenide Or Sulfide
Examiner : Cuong Q. Nguyen - Art Unit: 2811

#27
Prior Art
FJONES
9-25-01

INFORMATION DISCLOSURE STATEMENT

Hon. Commissioner of Patents and Trademarks,
Washington, D.C. 20231

Sir:

In accordance with 37 C.F.R. 1.98 copies of the following patents and/or publications are submitted herewith:

German Patent DE 196 49 684 C1 (Fröschle et al.), dated September 11, 1997, method for producing a titaniummonophosphide layer and using it;

European Patent Application EP 0 726 600 A2 (Tsu), dated August 14, 1996;

R. L. Ripley: "The Preparation And Properties Of Some Transition Phosphides", Journal of the Less-Common Metals, Vol.4, 1962, pp. 496-503;

I.M. Watson et al.: "Chromium-phosphorus films deposited by the pyrolysis of an organometallic precursor", Thin Solid Films, Vol. 196, No. 1, February 1, 1991, pp. L21-L24;

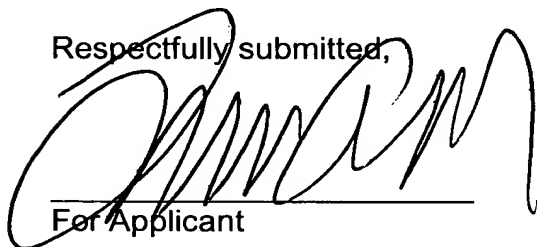
S. Motojima et al.: "Chemical vapour growth of HfP whiskers and their properties", Journal of materials Science, Vol. 31, 1996, pp. 5709-5715;

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T. Suren Lewkebandara et al.: "Precursor for the Low-Temperature Deposition of Titanium Phosphide Films", Chem. Mater., 1995, No. 7, pp. 1053-1054.

If no translation of pertinent portions of any foreign language patents or publications mentioned above is included with the aforementioned copies of those applications, patents and/or publications, it is because no existing translation is readily available to the applicant.

Respectfully submitted,



For Applicant

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Date: September 6, 2001

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